



**COMPONENT SPECIFICATION**

TITLE  
**SUBSTRATE, BEAM SPLITTER**

APPROVALS:	DATE	REV	DCN NO	BY	CHK	DCC	DATE
DRAWN: Billingsley	17 Oct 01	A	E960116-00-D	n/a	n/a	n/a	n/a
CHECKED: Coyne		B	E970065-00-D				
		C	E010140-00-D				
		D	E0102020-00-D				18 Oct 01

**Applicable Documents**

- LIGO-D960789-B-D Beam Splitter Substrate
- LIGO-E960094-B-D Mirror Blank Material, Beam Splitter
- LIGO-D960793-B-D Beam Splitter Blank

**Requirements**

**Physical Configuration**

According to  
 LIGO-D960789 Beam Splitter Substrate

Fabricate from  
 LIGO-E960094 Mirror Blank Material, Beam Splitter

**Serial Number**

The Serial number shall be of the format:  
 BSYY Where  
 YY is incremental for each optic.

**Registration Mark**

Registration mark shall be etched, ground or sandblasted coincident with the registration mark drawn on the Blank within 5 mm. The arrow orientation used on the Blank will be preserved if possible or changes reported in detail. Reference LIGO-D960793, Beam Splitter Blank.

**Side and Bevel Polish**

Sides and Bevels shall be polished from a five micrometer grit finish. These surfaces shall appear transparent with no grey, scuffs or scratches visible to the naked eye when viewed in normal room light against a black background.



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### Scratches and Point defects

#### Scratches

The total area of scratches within the central 80 mm diameter shall not exceed  $75 \times 10^3$  square micrometers (width times length.)

The total area of scratches outside the central 80 mm diameter shall not exceed  $750 \times 10^3$  square micrometers.

#### Point Defects

There shall be no more than 30 point defects within the central 80 mm diameter

There shall be no more than 100 point defects on the entire surface

Point defects of radius greater than 25 micrometers are treated like scratches for the purpose of this specification. Point defects of radius less than 2.5 micrometers are disregarded.

#### Inspection Method

1. The surface is examined visually by two observers independently. The examination is done against a dark background using a three-bundle fiberoptic illumination system of 200 W total power. A 100% inspection of the surface is carried out. Pits and scratches down to 2 micrometers in width can be detected using this method of inspection. Any scratches that are detected will be measured using a calibrated eyepiece.
2. Further inspection will be done with a 6X eyeglass using the same illumination conditions, again with two observers. Sleeks down to 0.5 micrometers wide can be detected using this method. The surface will be scanned along one or two chords from center to edge, then at ten positions around the edge, and ten to fifteen positions near the center.
3. An inspection is then carried out with a dark field microscope with a similar sampling frequency as described in section 2.

### Surface Figure, measured over the central 200 mm diameter

Surface 1: Nominal 25 nm sag.

The parabolic sag of the reflected wavefront is required to be between 39 nm and -25nm

Astigmatism: < 16 nanometers (surface peak to valley)

Surface 2: Nominally flat.

Measured with the wavefront transmitted through Side 2, passing through the material, reflected from Side 1 back along the same path. The single pass wavefront is calculated from this measurement in combination with an independent measurement of Side 1

The parabolic sag of the single pass transmitted wavefront is required to be between 14 nm and -50nm .

Astigmatism: < 23 nanometers (surface peak to valley)



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### Surface Errors, Surface 1 and Surface 2

All specified quantities refer to the physical surface of the optic.

The following root mean square standard deviation ( $\sigma_{\text{rms}}$ ) values are calculated from the phase maps which are to be provided with each optic.  $\sigma_{\text{rms}}$  is defined as the square root of the mean of the square of each pixel value. Known bad pixels are excluded from this calculation.

#### Low Spatial Frequency Band: $\leq 4.3 \text{ cm}^{-1}$

With piston, tip, tilt, power (best fit spherical surface) and astigmatism removed over the central 200 mm diameter aperture:

$$\sigma_{\text{rms}} < 3.2 \text{ nanometers}$$

With piston, tip, tilt, power (best fit spherical surface) and astigmatism removed over the central 80 mm diameter aperture:

$$\sigma_{\text{rms}} < 1.6 \text{ nanometers}$$

#### High Spatial Frequency Band: $4.3 - 7,500 \text{ cm}^{-1}$

$$\sigma_{\text{rms}} < 0.4 \text{ nanometers}$$

Measured at the following locations:

1. The center of the mirror substrate.
2. Four positions equally spaced along the circumference of a centered, 80 mm diameter circle.
3. Three positions equally spaced along the circumference of a centered, 200 mm diameter circle.



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Specification	Test Method	Frequency of Inspection	Data Delivered
Physical Dimensions	Visual Inspection	100%	Diameter, Thickness, Bevel dimension, Wedge angle.
Side and Bevel Polish	Visual Inspection	100%	Inspection Report included with Certification
Scratches and Point defects	Visual Inspection	100%	Hand sketch including scratch/pit dimensions
Registration Mark Location/Orientation	Visual Inspection	100%	Inspection Report included with Certification
Registration Mark Dimensions	Visual Inspection	100%	Inspection Report included with Certification
Identification Location	Visual Inspection	100%	Inspection Report included with Certification
Identification Serial number	Visual Inspection	100%	Inspection Report included with Certification
Surface Figure	Interferometry	100%	Surface Map
Surface Errors - Low Spatial Frequency	Interferometry	100%	Surface Map
Surface Errors - High Spatial Frequency	High resolution Surface Map	100%	Surface maps for 3 central locations. Numerical values included with Certification

Data:

Orientation: For the purpose of all data collection the Registration mark shall be at the top center of the optic.

Format: All Data shall be delivered according to Table 1. In addition to a hard copy, an electronic data set of the phase maps shall be delivered on IBM PC compatible disk in ASCII or Vision.OPD format.